



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

February 19, 2026	
IGI Report Number	LG774678156
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	PEAR BRILLIANT
Measurements	11.12 X 7.11 X 4.33 MM

GRADING RESULTS

Carat Weight	2.02 CARATS
Color Grade	D
Clarity Grade	VS 2

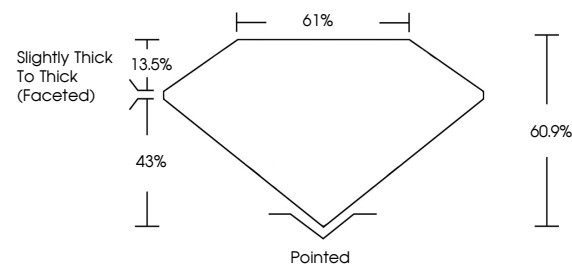
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	151 LG774678156

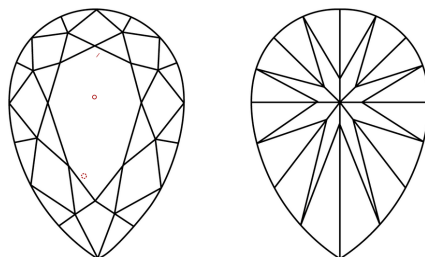
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG774678156
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

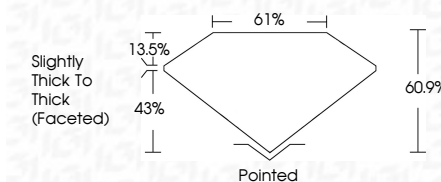
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www.igi.org

February 19, 2025	2022 CARATS
GI Report No LG774678156	D
PEAR BRILLIANT	VS 2
11.12 X 7.11 X 4.53 MM	60.1%
	61%
	Slightly thick to thick (Faceted)
	Pointed
	EXCELLENT
	EXCELLENT
	NONE
	ISS: LG774678156

Comments: This is a Chemically Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIA